

Docket No.: 50212-211



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kenichi ARIMURA, et al.

Serial No.: 09/807,902

Filed: April 19, 2001

For: WAFER SUPPORT IN SEMICONDUCTOR PRODUCTION APPARATUS

Group Art Unit: 1763

Examiner: R. Bueker

#6
3/8/02
MW

RESUBMISSION OF SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449, which were previously submitted September 17, 2001 and are not resubmitted herein. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

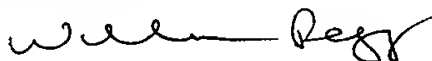
The previously submitted Information Disclosure Statement was filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No additional certification or fee is required.

09/807,902

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, was attached for the Examiner's information in the submittal dated September 17, 2001, as ^{was} ~~were~~ a copy of the International Preliminary Examination Report dated November 28, 2000 issued in the related PCT application.

Respectfully submitted,

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